



Attorney Docket No. 0756-7239

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/756,776

Filed: January 14, 2004

For: LASER IRRADIATION APPARATUS,

LASER IRRADIATION METHOD,

AND METHOD FOR

MANUFACTURING A

SEMICONDUCTOR DEVICE

) Group Art Unit: 2828

) Examiner: E. Unelus

) CERTIFICATE OF MAILING

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)

AMENDMENT AND RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.